

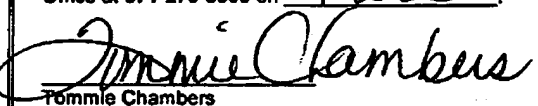
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Jaiswal	Docket No:	TI-34403.1
Serial No:	10/679,783	Examiner:	McDonald, Rodney Glenn
Filed:	10/6/2003	Art Unit:	1753
For:	CONTROL OF NICHROME RESISTOR TEMPERATURE COEFFICIENT USING RF PLASMA SPUTTER ETCH		

AMENDMENT UNDER 37 C.F.R. § 1.115

Assistant Commissioner For Patents  
Washington, DC 20231

<p><b>CERTIFICATION OF FACSIMILE TRANSMISSION</b></p> <p>I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at 571-273-8300 on <u>9-2-05</u>:</p> <p> Tommie Chambers</p>
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Dear Sir:

Responsive to the Office Action mailed May 2, 2005 in connection with the above identified application, Applicants respectfully submit the following remarks.